



3736

#7

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE
INFORMATION DISCLOSURE STATEMENT

APPLICANTS: Clasbrummel et al. CONFIRMATION NO. 4762
SERIAL NO.: 10/036,618 GROUP ART UNIT: 3736
FILED: December 21, 2001
TITLE: "METHOD AND APPARATUS FOR PREPARING AN ANATOMICAL IMPLANT"

Assistant Commissioner for Patents,
Washington, D.C. 20231

RECEIVED

MAR 03 2003

TECHNOLOGY CENTER R3700

S I R:

In accordance with the provisions of 37 C.F.R. §1.56, Applicants request that citation and examination of the following documents be made during the course of examination of the above-referenced application for United States Letters Patent.

AL German OS 198 28 003

AM German OS 39 33 142

EXPLANATION OF RELEVANCE

The above references were cited by the German Patent and trademark Office during examination proceedings for the German application corresponding to the present United States application. English translations of these references are not readily available to the Applicants, however, each of those references has an English Abstract attached thereto, which constitute a summary of its teachings.

Copies of each of the above references together with Form 1449 are submitted herewith.

As of the date of mailing of this Information Disclosure Statement, a first Office Action on the merits has not been received in connection with this application.

This Information Disclosure Statement is therefore in compliance with 37 C.F.R. §1.97(b)(3), and no fee is necessary.

All claims of the application are submitted to be patentable over the teachings of the above references, taken singly or in combination. Early consideration of the application is therefore respectfully requested.

Submitted by,

Steven H. Noll (Reg. 28,982)

SCHIFF, HARDIN & WAITE

CUSTOMER NO. 26574

Patent Department

6600 Sears Tower

233 South Wacker Drive

Chicago, Illinois 60606

Telephone: 312/258-5790

Attorneys for Applicants.

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service as First Class mail in an envelope addressed to: Assistant Commissioner for Patents, Washington, D.C. 20231 on February 21, 2003.

Steven H. Noll

STEVEN H. NOLL